Improved Photovoltaic Properties of Heterojunction Carbon Based Solar Cell

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ABSTRACT

Amorphous carbon (a-C) thin films have been synthesized by microwave (MW) surface wave plasma (SWP) chemical vapor deposition (CVD) on n-type silicon and quartz substrates, aiming at the application of the films for photovoltaic solar cells. Argon, acetylene and trimethylboron were used as a carrier, source and dopant gases. Analytical methods such as X-ray photoelectron spectroscopy (XPS), Hall Effect measurement, JASCO V-570 UV/VIS/NIR spectroscopy, Raman spectroscopy, Transmission electron microscopy (TEM) and Solar simulator were employed to investigate chemical, optical, structural and electrical properties of the a-C films. Two types of solar cells of configuration p-C/n-Si and p-C/i-C/n-Si have been fabricated and their current-voltage characteristics under dark and illumination (AM 1.5, 100 mW/cm²) have been studied. The two solar cells showed rectifying curves under the dark condition confirming the heterojunction carbon based solar cell between p-C and n-Si. When illuminated by the solar simulator light the devices showed photovoltaic behavior. The heterojunction device (p-C/i-C/n-Si) having inserted intrinsic carbon film between p-C and n-Si exhibited significant enhancement of the conversation efficiency (0.167% to 2.349%) over the device (p-C/n-Si).

Keywords: Carbon; Photovoltaic Properties; Heterojunction Solar Cell

1. Introduction

Various semiconductor materials have been used to fabricate solar cells that convert sunlight into electricity. Among them, silicon based solar cells are dominant in the market which are expensive, and thus not practical to use for daily life. Also, release of a toxic gas (SiO₂) while fabricating silicon based solar cells is discouraging for environment and consequently to human health. Therefore, the cost reduction of solar cell and establishment of environmentally friendly production process are very important for development and promotion of photovoltaic technology in the near future. One of the attractive alternatives is the application of carbon based solar cell that can be fabricated from cheap, abundant and nontoxic precursors [1,2]. Carbon an element of group IV in the periodic table existing in many forms with a wide range of optoelectronic properties has been found as a highly attractive material for its possible application in Photovoltaic (PV) solar cells [3]. It consists of a mixture of trihedral (sp²) and tetrahedral (sp³) configurations and hence possible to vary the optical band gap by simply varying the relative proportion of the sp²/sp³ hybridization [4].

Amorphous carbon (a-C) films have received considerable attention because of their unique properties such as extreme hardness and chemical inertness. Interestingly, these properties can be tailored over a wide range, which promotes its application in the semiconductor field [5,6]. These properties are attractive for optoelectronics device including photovoltaic solar cells. Optoelectronics properties of the a-C thin films strongly depend on the deposition method and other parameters. Generally, two methods; physical deposition or sputtering method and chemical vapor deposition (CVD) are used for synthesis of a-C films. The sputtering methods, such as ion beam sputtering [7,8], magnetron sputtering [9] and pulse laser deposition [8,10,11] usually use solid target, and the CVD methods, such as radio frequency (RF) plasma
CVD [12-14] and plasma-enhanced CVD [15,16] involve the decomposition of hydrocarbon source gas (C₂H₂, C₂H₄, CH₄ etc). The gaseous phase of carbon source used in CVD has the advantage of better control of chemical composition and bonding structure in the thin films over the solid source used in the physical deposition method. The a-C films were synthesized by various methods, and properties of the films were extensively studied for various applications. Some of the previous works were purely concentrated to develop a-C thin film based heterojunction solar cells [1,3,7-20].

The application of a-C on the semiconductor field was the subject of many investigations [21,22]. However, undoped a-C is weakly p-type [23] in nature, and the complex structure and presence of high density of defects restrict its ability to dope efficiently and are the main barrier for its application in various electronic devices, such as PV cells. When attempted to utilize such carbon as an alternative material in PV cells, control of optical band gap and conduction type through doping of carbon film are indispensable. The doping mechanism of amorphous semiconductors has always been an interesting issue. The semiconducting carbon films can be either intrinsic or they can be doped during or after the growth to make them extrinsic semiconductors [24,25].

In this work, we synthesized intrinsic and extrinsic (boron incorporated a-C) (a-C:B) thin films by microwave surface-wave plasma (MW-SWP) chemical vapor deposition (CVD), aiming the application of the films for photovoltaic solar cells. In other words, we prepared with/without intrinsic carbon films between crystalline Si and p-type a-C thin film, and compared their photovoltaic properties.

2. Experimental Setup

Amorphous carbon (a-C) thin films were deposited on n-type silicon (Si) wafer and quartz substrates by microwave (MW) surface wave plasma (SWP) chemical vapor deposition (CVD). Figure 1 shows schematic diagram of the CVD system. In this system, MW power, gas flow rate and deposition time-duration are controlled by touch-screen computer system. Because of the relatively large stage diameter (20 cm) of the CVD, it is possible to deposit a relatively large area a-C thin film or make simultaneous film deposition on various substrates in one experiment. The maximum MW power of the CVD system is 3 kW, whereas the stage temperature can be controlled up to 700°C. The MW-SWP is produce in a 300 GHz MW through a quartz window via slot antennae. The deposited films were characterized by X-ray photoelectron spectroscopy (XPS), Hall Effect measurement, JASCO V-570 UV/VIS/NIR spectroscopy, Raman spectroscopy, Transmission Electron Microscopy (TEM) and JASCO SS-200 W solar simulator at room temperature (25°C) in dark and under AM 1.5 simulated solar radiation.

3. Results and Discussion

Chemical compositional analysis of the incorporated boron into the a-C (a-C:B) film was performed by XPS measurement (SSX-100) utilizing Al Kα (hv = 1486.6 eV) radiation. Figure 2 shows typical XPS spectrum of the a-C film. The XPS spectrum of the B doped film shows the presence of B, indicating the successful incorporation of B (0.35 at. %) in the film. In this work, we found high concentration of B into the film compared to that of our previous work [28] but we believed that the doping efficiency is to be low. The detail quantitative study about the chemical composition of B incorporated a-C...
film is underway. Furthermore, the result of Hall effects measurement has confirmed that the B is incorporated in the film; (the film is p-type semiconducting in nature). From the measurements of optical reflectance and transmittance, the optical band gap of the a-C thin film was determined by the Tauc relation [29],

\[(\alpha h\nu)^{1/2} = B(E_{opt} - \nu)\]

where B is the density of the localization state constant and \(E_{opt}\) is the optical gap obtained from the extrapolation of the linear part of the curve at the absorption coefficient \(\alpha = 0\). The result showed that the optical band gap of the film is 1.2 eV. The absorption coefficient \(\alpha (10^3 \sim 10^5 \text{cm}^{-1})\) of the film is calculated by the spectral reflectance and transmittance and films thickness data.

The structural morphology of the a-C film was characterized by transmission electron microscopy (TEM). Figure 3 shows the some graphene layers (17 - 18 layers) are grown inside the a-C film. In the inset of the figure, the intensity pattern of the graphene layers (an interplanar spacing is about 0.35 nm) is shown. It corresponds to the graphite spacing [30]. Raman spectrum shows a good agreement of graphene structure formation into the carbon film.

Raman spectroscopy is widely used for the analysis of carbon and carbon-related materials [31,32]. Raman scattering is used as a powerful technique to understand the microstructure changes of a-C films. Raman spectrum provided a wide range of structure and phase disorder information. The C-C bonding configurations are deduced from the Raman scattering spectrum analysis. The analysis of such spectrum is usually made by drawing an analogy with graphite [33]. Raman spectrum show a main peak centered at approximately 1580 cm\(^{-1}\) (known as G peak), which corresponds to the only Raman-active mode in mono-crystalline graphite (stretching vibration mode of the C=C double bond in the plane of hexagonal layers), while the low wave structure is related to the disorder-induced centered at approximately 1350 cm\(^{-1}\) (known as D peak), which appears in micro-crystalline or defective graphite.

Figure 4 shows Raman spectrum of a-C film, performed at room temperature. Major three peaks known as D, G and 2D peaks are clearly observed and centered at approximately 1351.4 cm\(^{-1}\), 1580.4 cm\(^{-1}\) and 2701.2 cm\(^{-1}\) respectively. It is reported that the D-peak represents disordered sp\(^2\)-hybridized carbon with an amount of sp\(^3\)-hybridized carbon, while the G-peaks represents graphite-like sp\(^2\)-hybridized carbon in the deposited film [34]. The presence of 2D peak shows a good agreement of graphene structure formation inside the a-C film.

The purpose of this work is to deposit semiconducting a-C film applicable for photovoltaic solar cells. JASCO SS-200W solar simulator was used to measure photovoltaic characteristics of the a-C thin film based solar cells. Figure 5 shows a schematic diagram of two configurations, namely (a) p-C/n-Si and (b) p-C/i-C/n-Si (by inserting i-C layer (110 nm) between p-C and n-Si).
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front and back contacts of the cells were made with semi-transparent gold (Au (~30 nm) and gold antimony (Au-Sb) (~100 nm) respectively.

Current-voltage (I-V) characteristics of the above configurations; (p-C/n-Si and p-C/i-C/n-Si) under dark and illumination are shown in Figure 6. Both configurations showed rectifying curve in dark [18,20] indicating the formation of a heterojunction solar cell between p-C film and n-type silicon. When illuminated by the light, the both configuration showed photovoltaic behavior; maximum open-circuit voltage ($V_{oc}$), short circuit current density ($J_{sc}$), fill factor (FF) and conversion efficiency ($\eta$) are summarized in Table 1.

It is observed that the device (p-C/i-C/n-Si) inserted intrinsic carbon film (110 nm) between p-C and n-Si exhibited significant enhancement of photovoltaic characteristics over the device (p-C/n-Si). In addition, we prepared three different devices (p-C/i-C/n-Si) with different intrinsic layer thickness (35 ~ 110 nm) for reference. The results (Table 1) show that the current density increased with increasing thickness of the intrinsic layer. This is attributed to increase photo absorption, better carrier separation and transport and reduce defect of interface region due to the intrinsic layer. The conversation efficiency of the solar cells is still low due to high defect density and recombination on the surface and inside the a-C. In addition, incident light energy loss occurred inside the electrode (light is absorbed by gold film) [35]. Thus, a large portion of the light generated electron-hole pairs will combine at the surface and inside the a-C films, and only a few of them can contribute to the energy conversion. The preliminary results show that the power conversation efficiencies of the solar cells are low. However, the results can be important references for further development of reasonably high efficiency a-C thin film based solar cells.

The quantum efficiency (QE) of the solar cells configurations; p-C/n-Si and p-C/i-C/n-Si are shown in Figure 7. Both configurations (p-C/n-Si and p-C/i-C/n-Si) have wide range of wavelength from 300 nm to almost 1000 nm. It is clear that the QE of configuration p-C/i-C/n-Si has improved significantly compared to that of p-C/n-Si configuration due to the absorption of intrinsic layer.

4. Conclusion

Carbon thin films deposited on Si and quartz substrate by microwave surface wave plasma CVD, using Acetylene, Argon and trimethyl boron as source, carrier and dopant gases. The structural and electrical properties of the films were investigated by the standard characterization techniques. Boron incorporation in the film has been confirmed by XPS measurement. Structural properties of the

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Table 1. Photovoltaic parameters of two heterojunction carbon solar cells of different configurations (p-C/n-Si and p-C/i-C/n-Si).

<table>
<thead>
<tr>
<th>Structure</th>
<th>$J_{sc}$ (mA/cm$^2$)</th>
<th>$V_{oc}$ (V)</th>
<th>FF</th>
<th>$\eta$ (%)</th>
</tr>
</thead>
<tbody>
<tr>
<td>p-C/n-Si</td>
<td>3.28</td>
<td>0.20</td>
<td>0.24</td>
<td>0.15</td>
</tr>
<tr>
<td>p-C/i-C(35 nm)/n-Si</td>
<td>6.83</td>
<td>0.28</td>
<td>0.27</td>
<td>0.51</td>
</tr>
<tr>
<td>p-C/i-C(80 nm)/n-Si</td>
<td>19.47</td>
<td>0.28</td>
<td>0.26</td>
<td>1.41</td>
</tr>
<tr>
<td>p-C/i-C(110 nm)/n-Si</td>
<td>28.77</td>
<td>0.34</td>
<td>0.24</td>
<td>2.34</td>
</tr>
</tbody>
</table>

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Figure 6. The Current-voltage characteristics of the p-C/n-Si and p-C/i-C/n-Si heterojunction carbon based solar cells under dark and light illumination (AM 1.5, 100 mW/cm$^2$).

Figure 7. The spectral photoresponse characteristics of p-C/n-Si and p-C/i-C/n-Si heterojunction carbon based solar cells.
films were characterized by TEM and Raman. We fabricated four types of photovoltaic solar cells of configuration p-C/n-Si and p-C/i-C/n-Si (i-C film thickness: 35, 85 and 110 nm) and characterized their photovoltaic properties. All the configurations displayed photovoltaic behavior under dark and light illumination. The device (p-C/i-C/n-Si) inserted intrinsic carbon film between p-C and n-Si exhibited significant enhancement of the photovoltaic characteristics over the device without intrinsic layer (p-C/n-Si). In addition, the current density is increased with increasing intrinsic layer (i-C) thickness.

5. Acknowledgements

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REFERENCES


